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PTO/SB06A (10-01)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		EXAMINER NAME:			
Sheet 1 of 1		First Named Inventor: YUE XIAO et al.			
		Filing Date: 03/01/2002		Group Art: 2812	
<b>U.S. PATENT DOCUMENTS</b>					
*Examiner Initials	Cite No.	Document Number Number - Kind Code <sup>2</sup> (if known)	Pub. Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages
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<b>FOREIGN PATENT DOCUMENTS</b>					
*Examiner Initials	Cite No.	Foreign Patent Document Country Code <sup>2</sup> -Number <sup>2</sup> -Kind Code <sup>2</sup> (if known)	Pub. Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages
DA		JP 10-101906A (45-753)	4/21/98	Shinetsu Kagaku	
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EXAMINER SIGNATURE		DATE CONSIDERED 06/22/03			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					

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